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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2813
Examiner: Mr. Jack S. J. Chen

In Re PATENT APPLICATION of:

Applicant(s): Toshikazu MIZUKOSHI)

Serial No.: 10/635,506)

Filed: August 7, 2003)

For: METHOD OF FABRICATING A
SEMICONDUCTOR DEVICE HAVING
TRENCHES)

Docket No.: OKI 361)

**PETITION FOR
THREE-MONTH
EXTENSION OF TIME**

April 12, 2005

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

04/13/2005 SZEWDIE1 00000080 10635506

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Sir:

It is respectfully requested that the period for replying to the Examiner's Action dated October 18, 2004, be extended for three months under the provisions of 37 C.F.R. 1.136(a).

The applicable extension fee of \$1,020.00 pursuant to 37 C.F.R. 1.17(a)(3) is submitted herewith.

Should this remittance be accidentally missing or insufficient, the Commissioner is hereby authorized to charge the fee to our Deposit Account No. 18-0002 and advise us accordingly. A duplicate copy of this paper is enclosed.

Respectfully submitted,

Robert H. Berdo, Jr. (Reg. No. 38,075)
RABIN & BERDO, PC
Customer No. 23995
Telephone: 202-371-8976
Facsimile: 202-408-0924

April 12, 2005

Date

FEE ENCLOSED: \$1,020.00
Please charge any further
fee to our Deposit Account
No. 18-0002

RHB:vm